

Docket No.: 204552031400
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Nobuhiro OHKUBO et al.

Application No.: 10/786,479

Confirmation No.: 3112

Filed: February 26, 2004

Art Unit: 2828

For: SEMICONDUCTOR LASER DEVICE AND
MANUFACTURING METHOD THEREOF

Examiner: Tod Thomas Van Roy

AMENDMENT UNDER 37 CFR 1.111

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Action dated April 24, 2007, please amend this application as follows.

Amendments to the Claims begin on page 2.

Remarks/Arguments begin on page 5.